



648.41969CX1

AF/LFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: G. SAITO, et al.  
Serial No.: 10/658,393  
Filed: September 10, 2003  
For: METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE  
Art Unit: 2823  
Examiner: Fernando L. Toledo  
Confirmation No. 2265

**AMENDMENT AFTER FINAL REJECTION**

**Mail Stop: AF Amendment – No fee**

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 26, 2005

Sir:

In response to the final Office Action mailed January 26, 2005, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.